

IFW



Docket No.: 060188-0807

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 20277  
Osamu KUSUMOTO, et al. : Confirmation Number: 4190  
Application No.: 10/801,606 : Group Art Unit: 2811  
Filed: March 17, 2004 : Examiner: HU, Shouxian

For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME

**RESPONSE TO RESTRICTION REQUIREMENT**

Mail Stop Restriction Requirement  
Honorable Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Noting the Office Action of June 30, 2005 wherein restriction has been required, Applicant hereby elects Group I and Species 1, the embodiment of Figures 1-2, and identifies claims 1-9 as reading thereon, for prosecution in the above-identified application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Michael E. Fogarty  
Registration No. 36,139  
**Please recognize our Customer No. 20277  
as our correspondence address.**

600 13<sup>th</sup> Street, N.W.  
Washington, DC 20005-3096  
Phone: 202.756.8000 MEF:dmd  
Facsimile: 202.756.8087  
**Date: July 27, 2005**